A 3D finite element mesh of a gating foil, rendered in a golden-brown color. The foil is a long, thin, rectangular structure with a central section that is wider and thicker than the ends. The mesh is composed of many small, interconnected triangles. The foil is shown in a perspective view, with a dashed grid in the background. A small 3D coordinate system with x, y, and z axes is visible in the lower right corner of the grid.

Improvement of Garfield++ simulation for the gating foil

T. Ogawa (SOKENDAI)

Status in the past 3 years

Simulation side:

- > Prediction of performance of the gating foil under higher B. (+ understanding of behavior)
- > Simulation did not fit with data under B.
- > Behavior under B is very suspicious.

Experimental side:

- > A method for evaluating transmission has been modified:

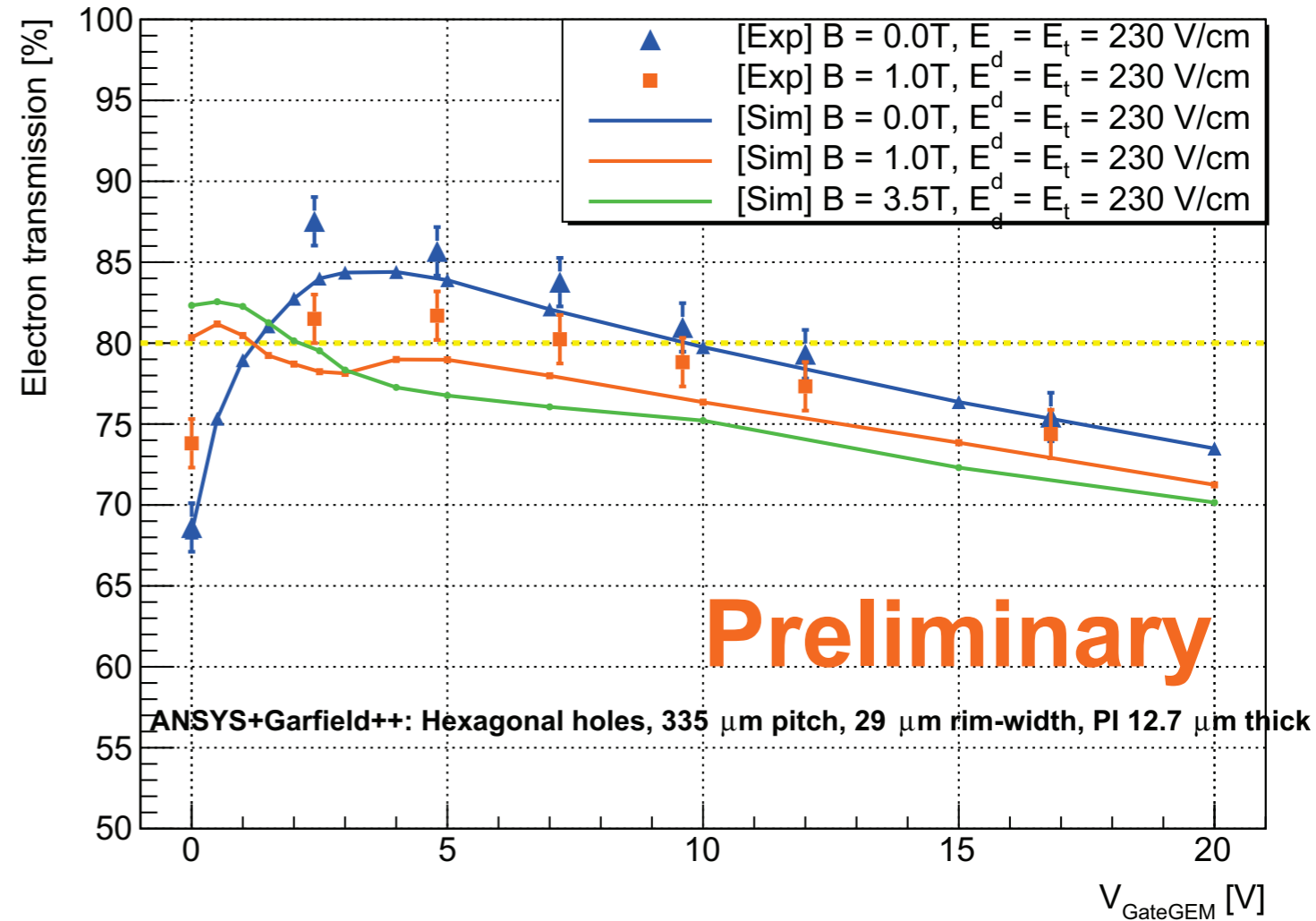
Using only an open state data.

Two data set (normal/reverse voltage of Edrift) are not necessary.

<http://www-jlc.kek.jp/jlc/sites/default/files/7.27SagaYamashita.pptx>

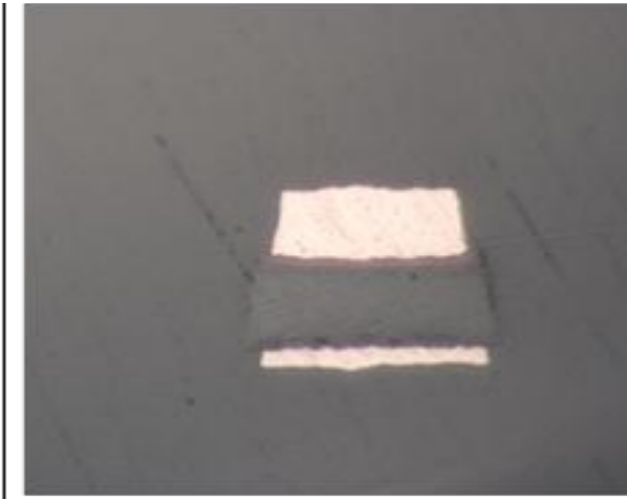
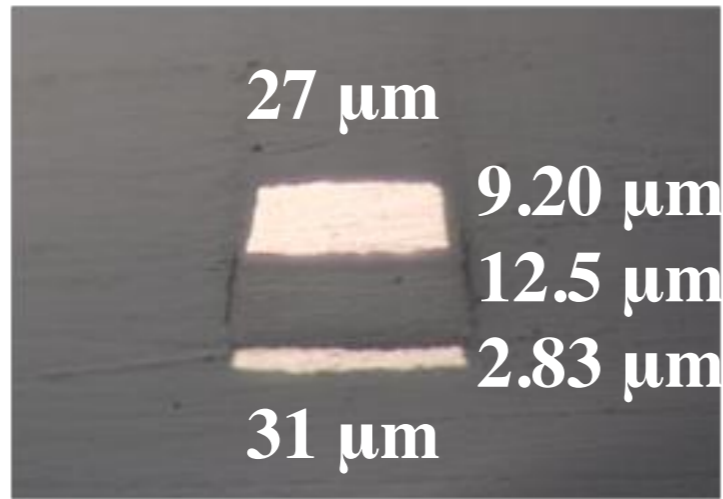
Comparison of Electron transmission between Exp. and Sim.

Exp vs Sim (Fujikura Type 3)



Geometries for the simulation

Smooth
trapezoidal



Not smooth
trapezoidal
It seems to have
protrusions..



Geometry parameters

“Development of gating foils to inhibit ion feedback using FPC production techniques”

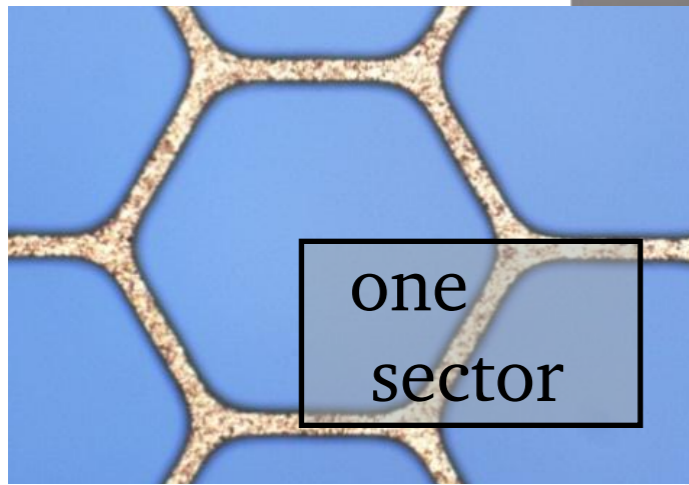
Daisuke Arai (presented at MPGD2015)

Measurement results

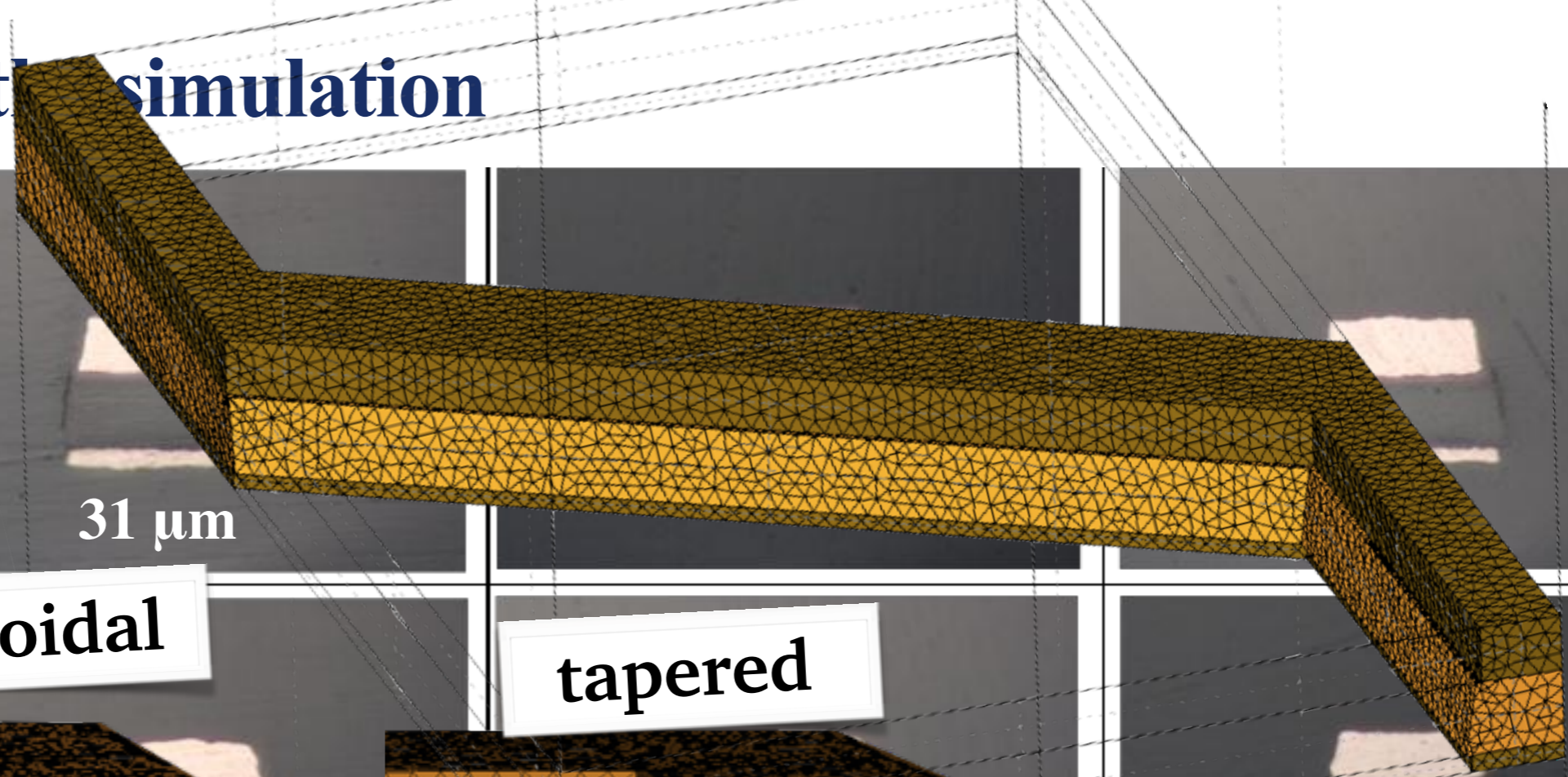
	Rim width (um)		Copper thickness(um)	
	F-side	B-side	F-side	B-side
Ave.	26.74	30.96	9.20	2.83
Max-Min	6.87	7.27	3.19	0.89
3σ	4.66	5.03	2.33	0.69

Item	Gating foil
Hole size	304μm
Hole pitch	335μm
Rim width : F-side	27μm
Rim width : B-side	31um
Insulator thickness	12.5μm
size	100mm x 100mm
Processing time	70min (only laser)
Optical aperture ratio	82.3%

Geometries for the simulation



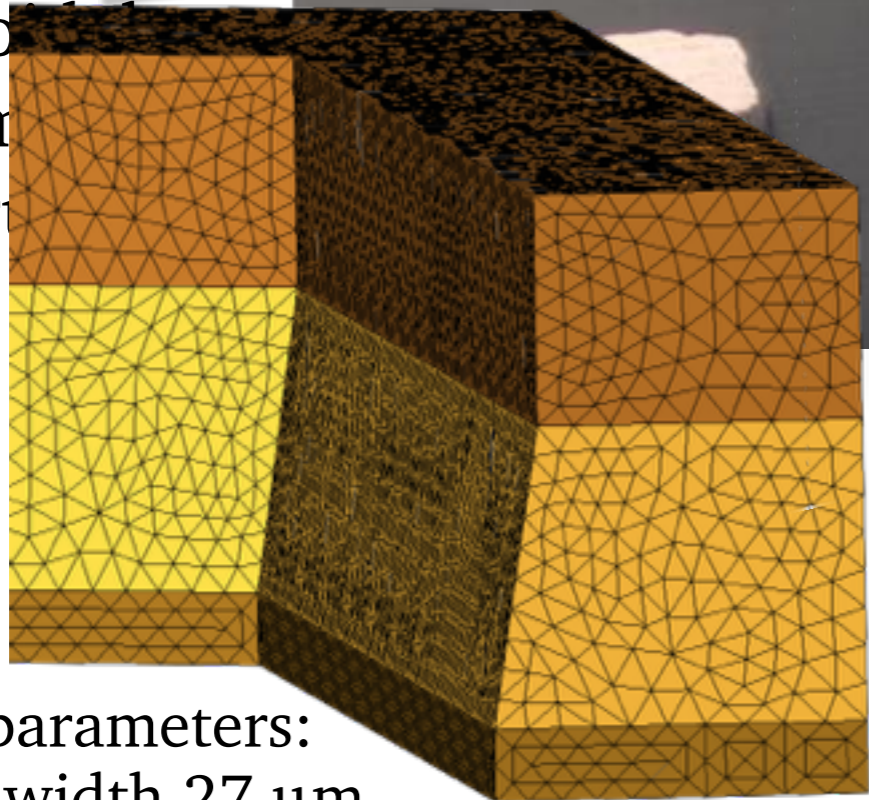
one sector



31 μm

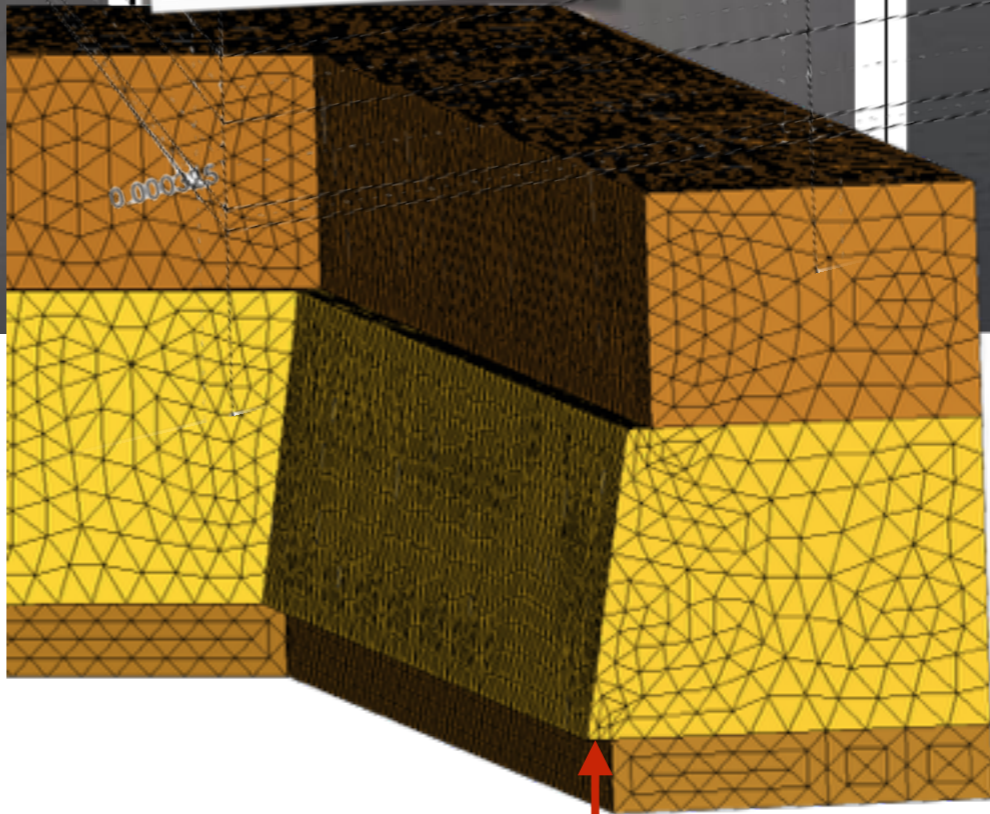
Not smooth
trapezoidal
It seems
protrusion

trapezoidal



geometrical aperture 82.3%

tapered



1 μm protrusion.

upper surface aperture 84.5%

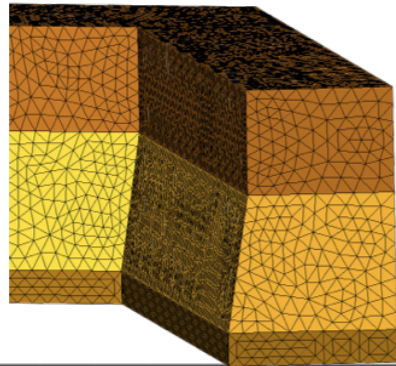
geometrical aperture 81.2%

Common parameters:
upper rim width 27 μm
lower rim width 31 μm
diel. thickness 12.5 μm
upper rim thick. 9.5 μm
lower rim thick. 3.0 μm

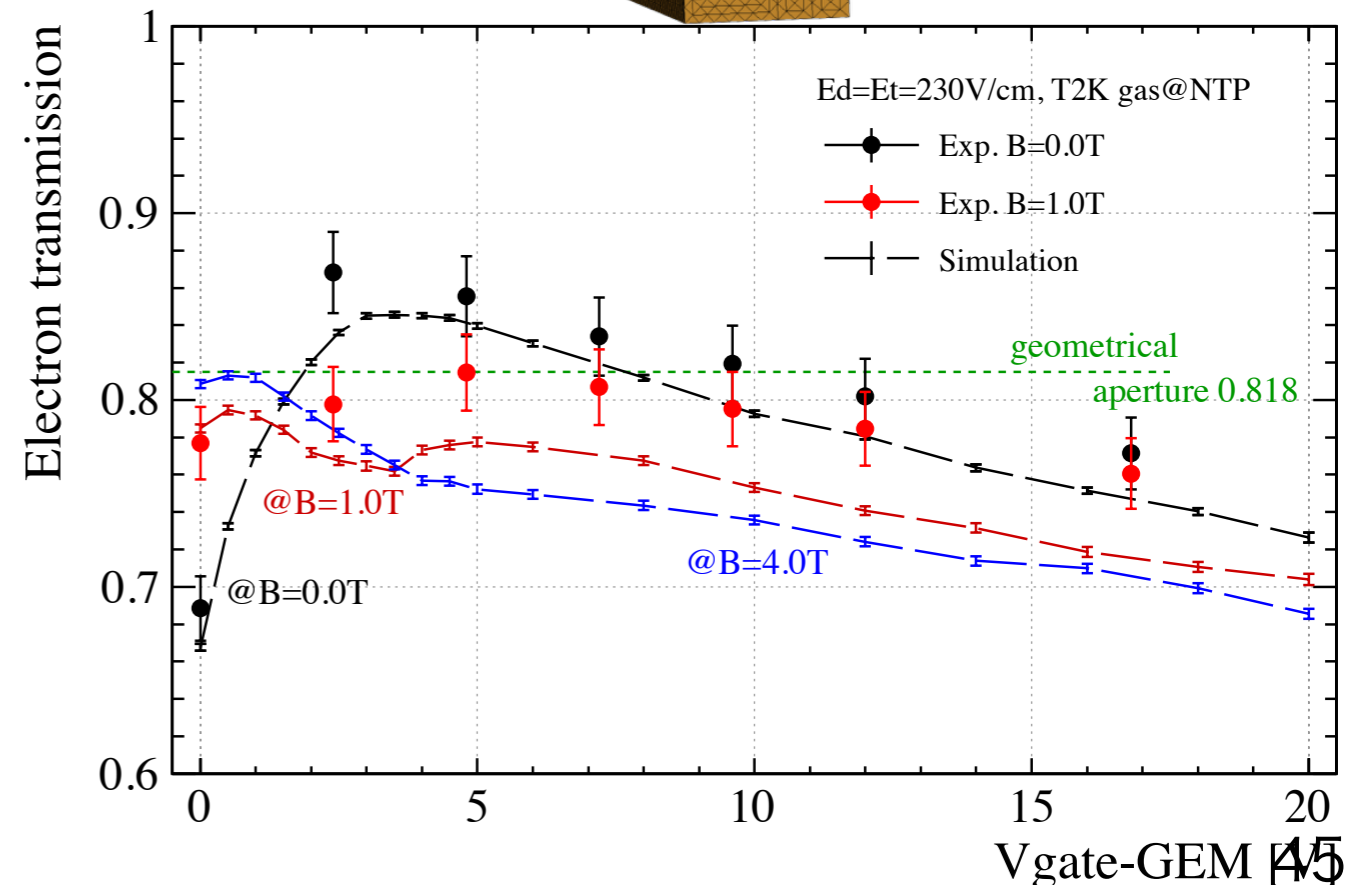
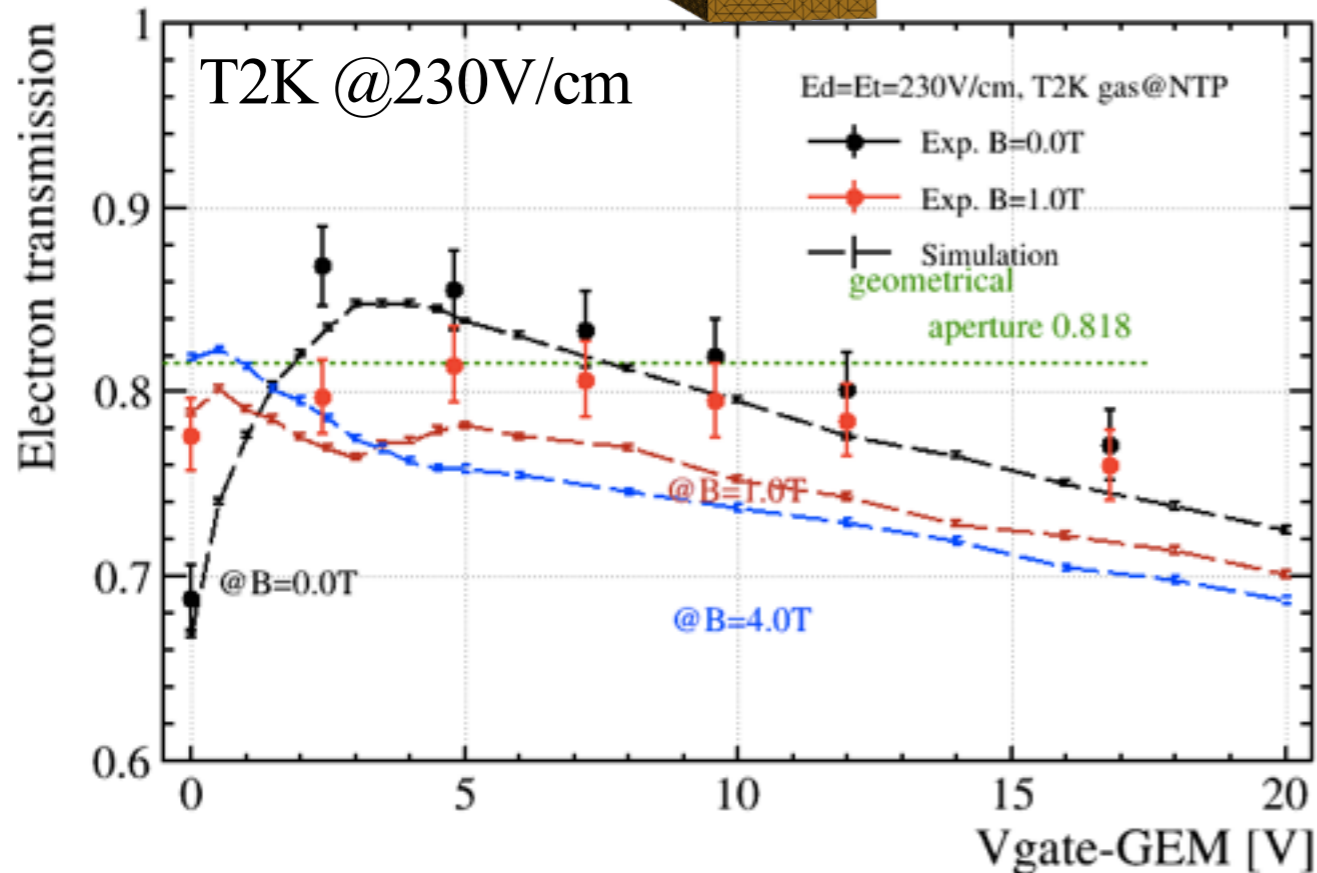
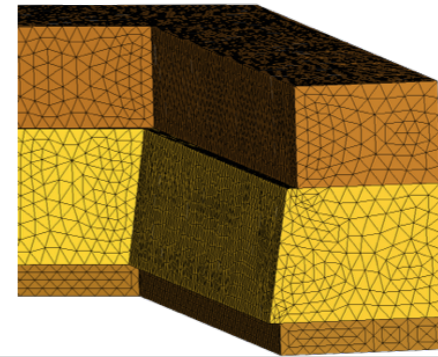
Simulation

Avalanche Microscopic,
with the “default” setting
originally implemented in garfield

trapezoidal

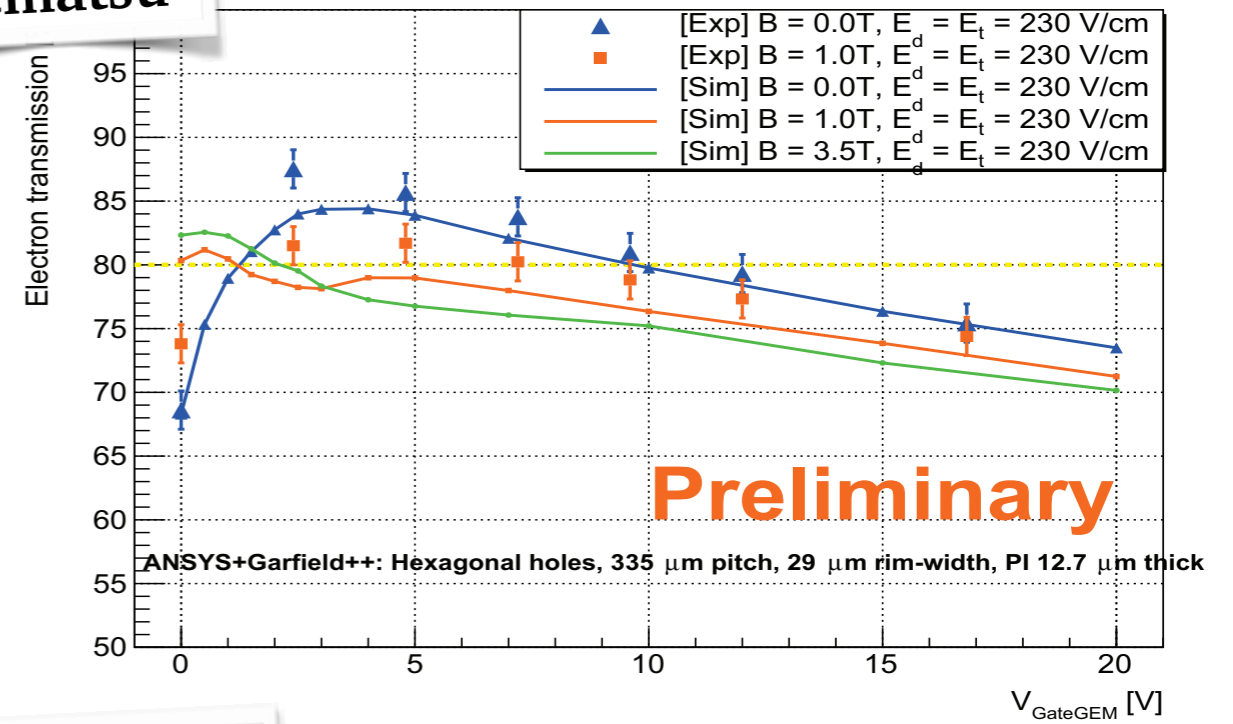


tapered



Ikematsu

Exp vs Sim (Fujikura Type 3)



Preliminary

Simulation

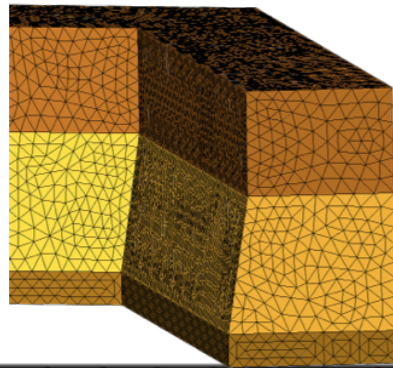
There is a switch on “Null collision steps”

Avalanche Microscopic,
with “Null collision steps”
originally implemented in garfield

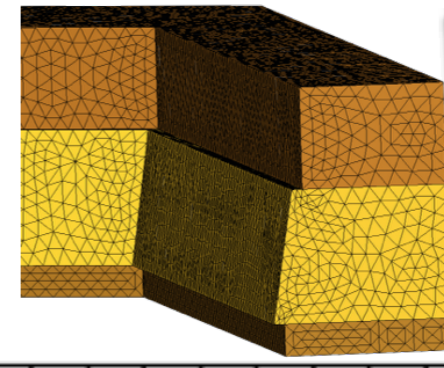
E-field is updated
in each step after sampling time Δt
even if the step is null-collision.

According to a developer
this was supposed that
more precise tracking is given.

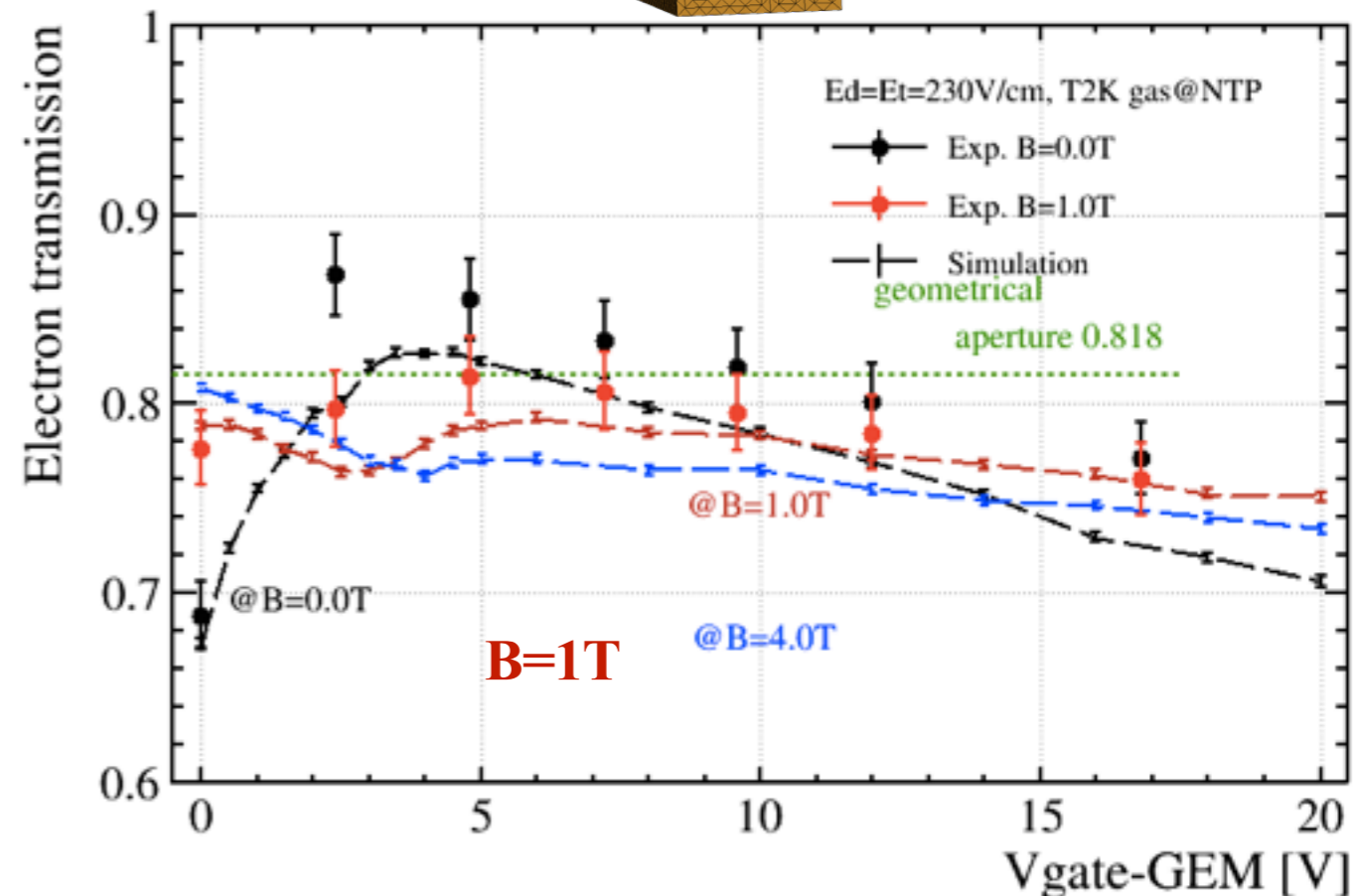
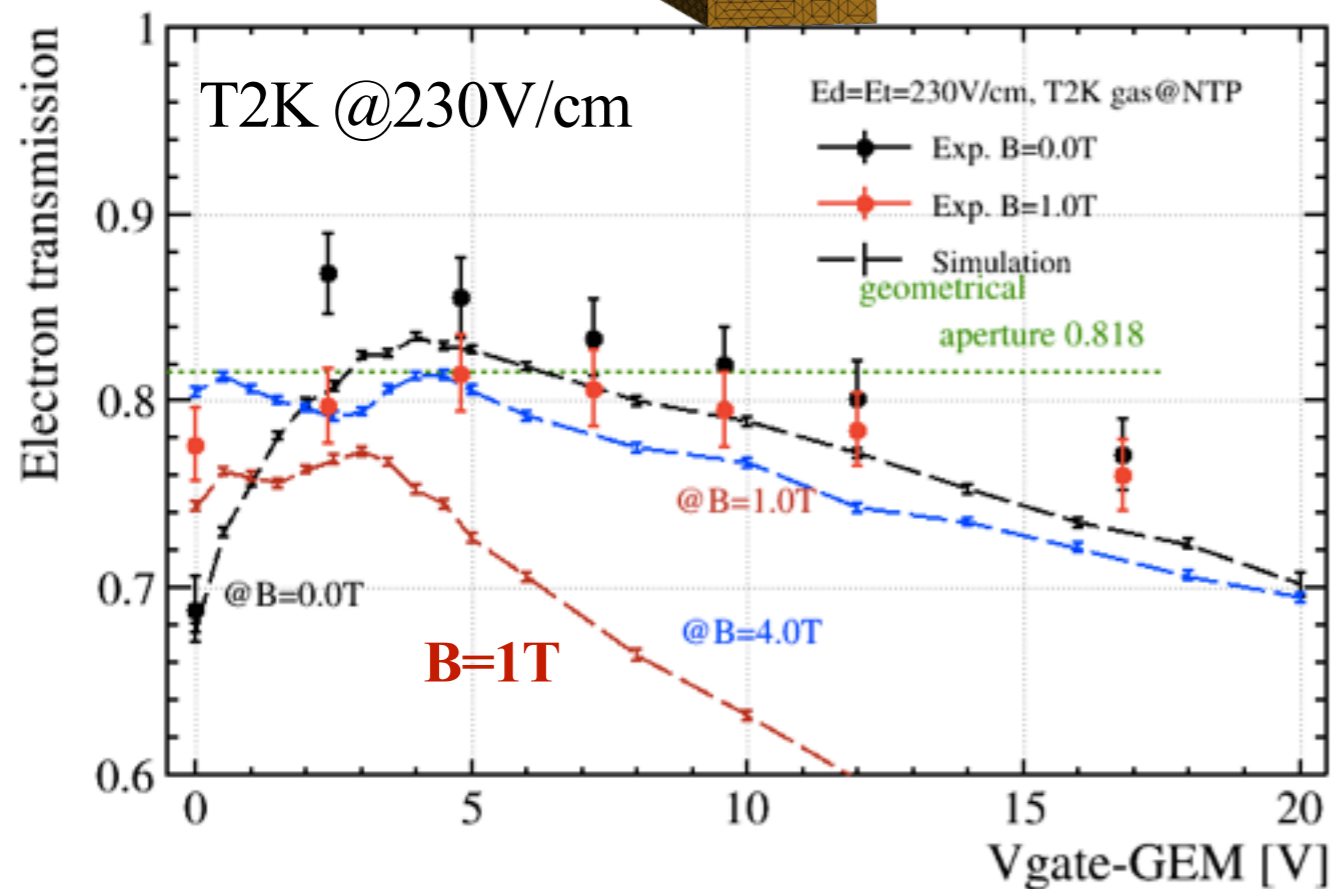
trapezoidal



seems to be buggy?
results are strange ...
even for 0 T ...



tapered



Simulation: AvalancheMicroscopic

Avalanche Microscopic function,

1). An electron trajectory is calculated based on given sampling time Δt ($= -\langle \tau \rangle \log(u)$ $u[0,1]$),

2). Electron kinetic energy ϵ' after Δt is evaluated

$$\epsilon' = \epsilon + \underbrace{q\mathbf{v} \cdot \mathbf{E}\Delta t + \frac{q^2}{2m_e} \mathbf{E}^2 \Delta t^2}_{\text{A change of the kinetic energy after } \Delta t}.$$

A change of the kinetic energy after Δt

\mathbf{v} and \mathbf{E} do not have time dependence, initial information are continuously used during Δt

(acceleration and deceleration are not sufficient.)

In reality,

E-field dramatically varies.

especially at around geometry.

\mathbf{v} and \mathbf{E} should be time-dependent variables

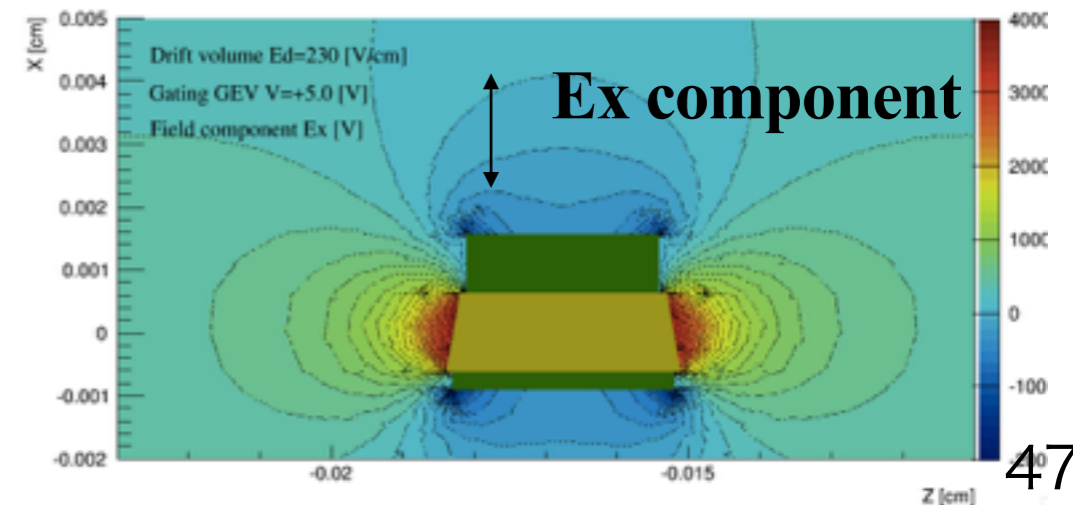
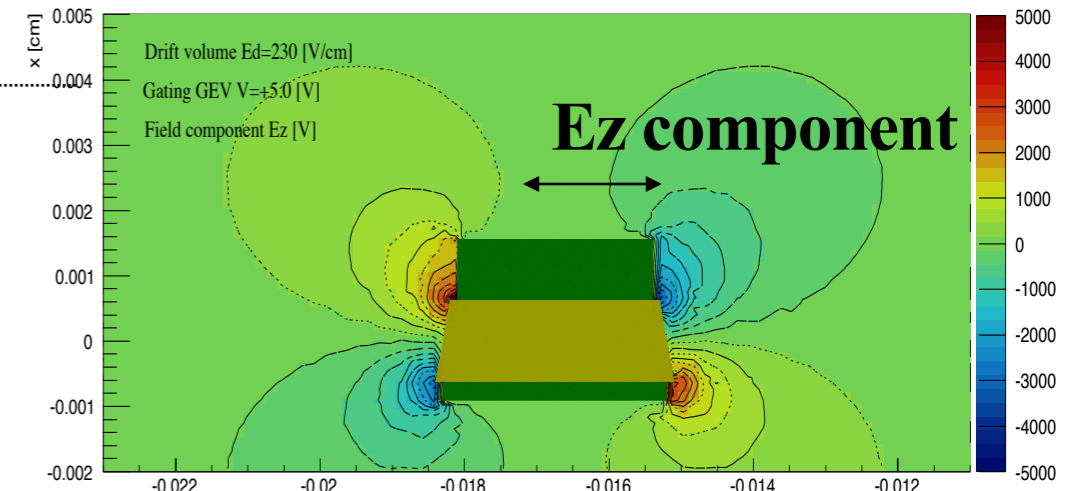
like $\mathbf{v}(t)$ and $\mathbf{E}(r(t))$,

<https://cds.cern.ch/record/1500583/files/CERN-THESIS-2012-208.pdf>

Heinrich Schindler,

Ph.D thesis ``Microscopic Simulation of Particle Detector'', CERN-THESIS-2012-208, 13/12/2012

p22 ~ p25



Simulation: Avalanche Microscopic w/ sub-step

Avalanche Microscopic function,

<https://cds.cern.ch/record/1500583/files/CERN-THESIS-2012-208.pdf>
 Heinrich Schindler,
 Ph.D thesis "Microscopic Simulation of Particle Detector",
 CERN-THESIS-2012-208, 13/12/2012

1). An electron trajectory is calculated based on given sampling time Δt ($= -\langle \tau \rangle \log(u)$ $u[0,1]$), p22 ~ p25

2). Electron kinetic energy ϵ' after Δt is evaluated

$$\epsilon' = \epsilon + \underbrace{q\mathbf{v} \cdot \mathbf{E}\Delta t + \frac{q^2}{2m_e}\mathbf{E}^2\Delta t^2}_{\text{change of the kinetic energy after } \Delta t}$$

change of the kinetic energy after Δt

Defined sub-step time δt

$\delta t (= \Delta t/N)$ recover above First approximation with $N=1$

$$\epsilon' = \epsilon + \sum_i^N \underbrace{q\mathbf{v}_i(\mathbf{E}_{i-1}, \delta t_i)}_{\text{time dependent v}} \cdot \underbrace{\mathbf{E}_i(\mathbf{r}_{i-1}(\delta t_{i-1}))}_{\text{time dependent E}} \delta t_i + \sum_i^N \frac{q^2}{2m_e} \mathbf{E}_i(\mathbf{r}_{i-1}(\delta t_{i-1}))^2 \delta t_i^2$$

subscripts i, i-1 is not checked carefully

v depends on E and δt
 E depends on r
 r depends on δt

A program has to access a field map many times
 Huge CPU consumption and time is necessary.

If the field map is precisely generated, more time is needed

Simulation: Avalanche Microscopic w/ sub-step approx.

Avalanche Microscopic function,

<https://cds.cern.ch/record/1500583/files/CERN-THESIS-2012-208.pdf>
 Heinrich Schindler,
 Ph.D thesis "Microscopic Simulation of Particle Detector",
 CERN-THESIS-2012-208, 13/12/2012

1). An electron trajectory is calculated based on given sampling time Δt ($= -\langle \tau \rangle \log(u) \ u[0,1]$), p22 ~ p25

2). Electron kinetic energy ϵ' after Δt is evaluated

$$\epsilon' = \epsilon + \underbrace{q\mathbf{v} \cdot \mathbf{E}\Delta t + \frac{q^2}{2m_e}\mathbf{E}^2\Delta t^2}_{\text{change of the kinetic energy after } \Delta t}$$

change of the kinetic energy after Δt

Defined sub-step time δt $\delta t (= \Delta t/N)$ recover above First approximation with $N=1$

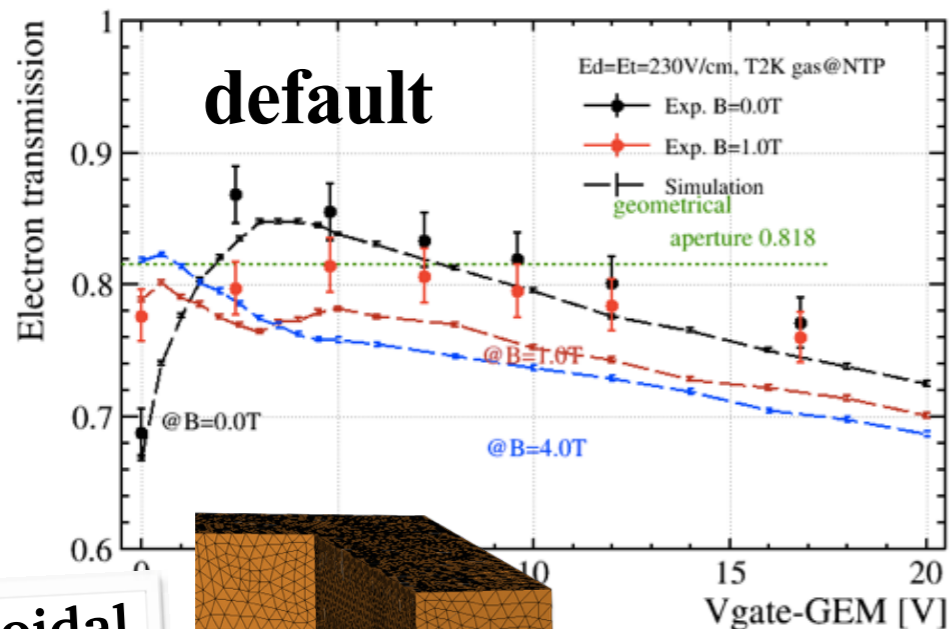
I check E' ($v(\text{initial}) * \Delta t$)

\longrightarrow $d\mathbf{E} = \mathbf{E}_{\text{initial}} - \mathbf{E}'_{\text{after } \Delta t}$ \longrightarrow continuously include the variation as $\mathbf{E} - \frac{d\mathbf{E}}{N}i$

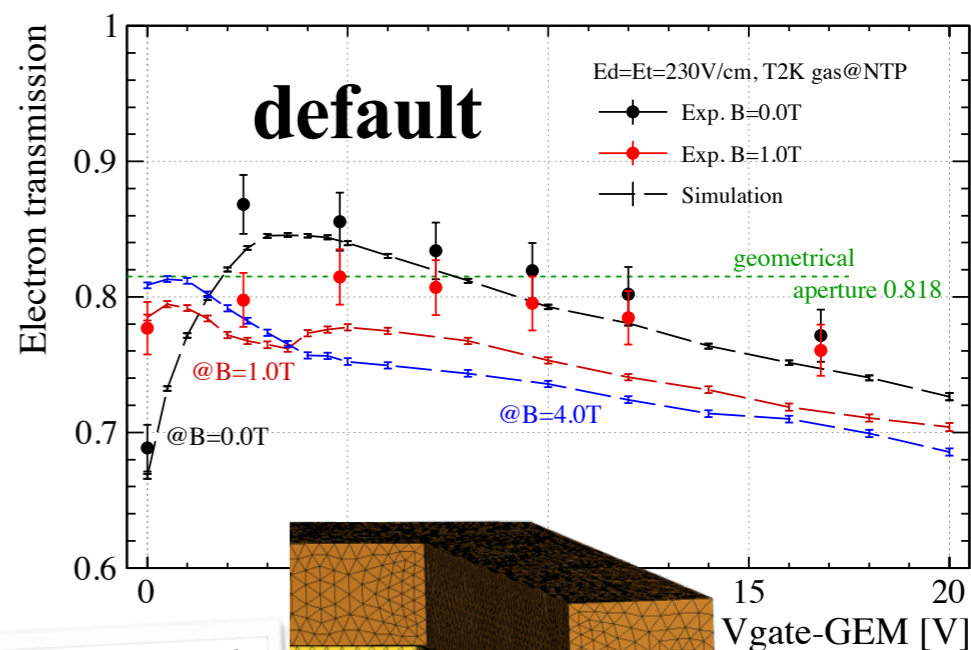
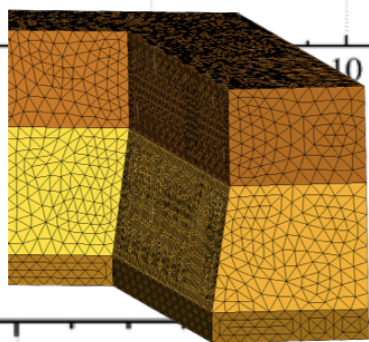
$$\epsilon' = \epsilon + \sum_i^N \underbrace{q\mathbf{v}_i \left(\mathbf{E} - \frac{d\mathbf{E}}{N}i, \delta t_i \right)}_{\text{time dependent v}} \cdot \left(\mathbf{E} - \frac{d\mathbf{E}}{N}i \right) \delta t_i + \sum_i^N \frac{q^2}{2m_e} \left(\mathbf{E} - \frac{d\mathbf{E}}{N}i \right)^2 \delta t_i^2$$

Under the assumption :
the variation of the E-field
b/w $\mathbf{E}(\mathbf{r})$ and $\mathbf{E}'(\mathbf{r}')$ (within Δt)
is linearly changed.

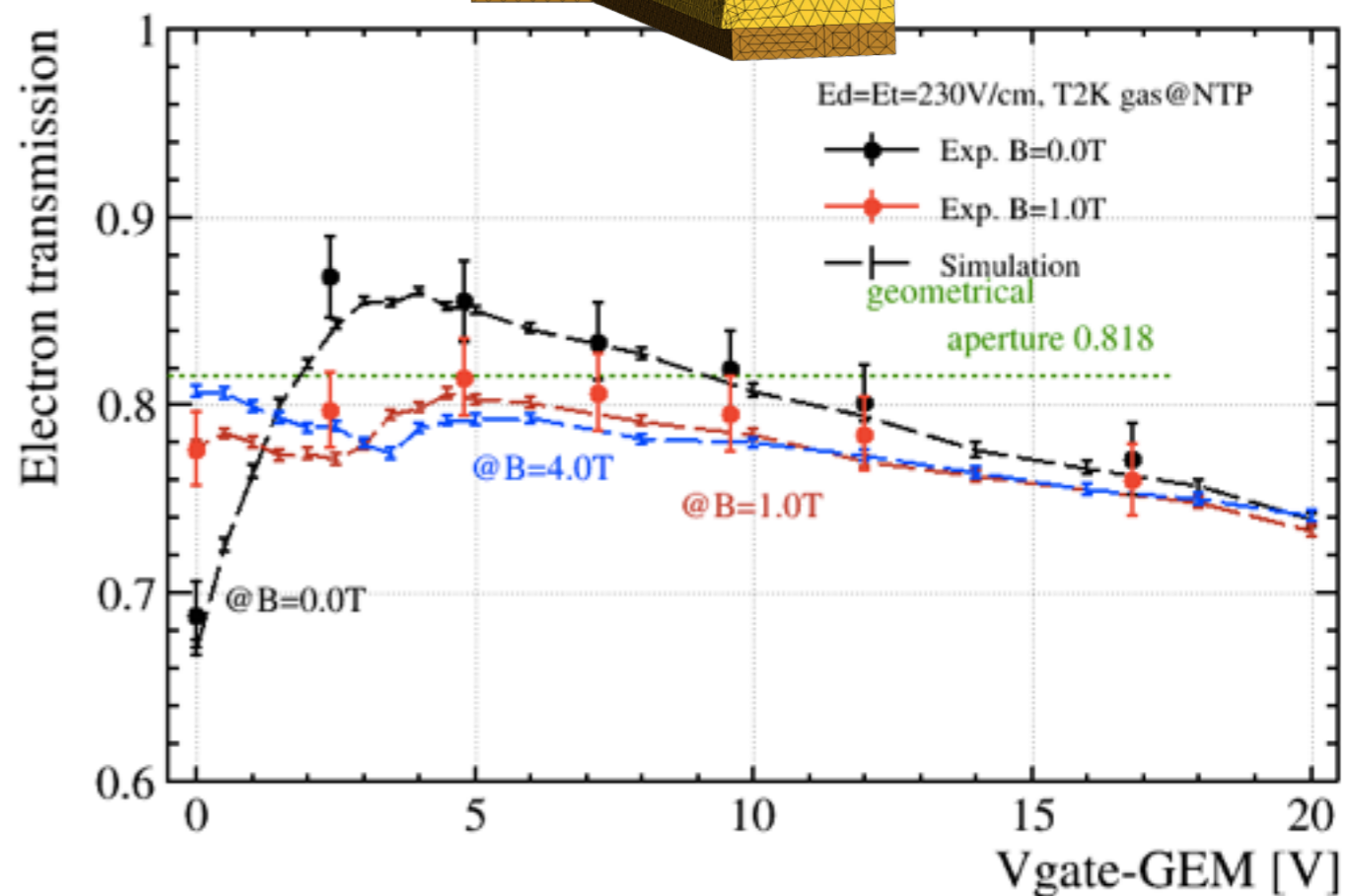
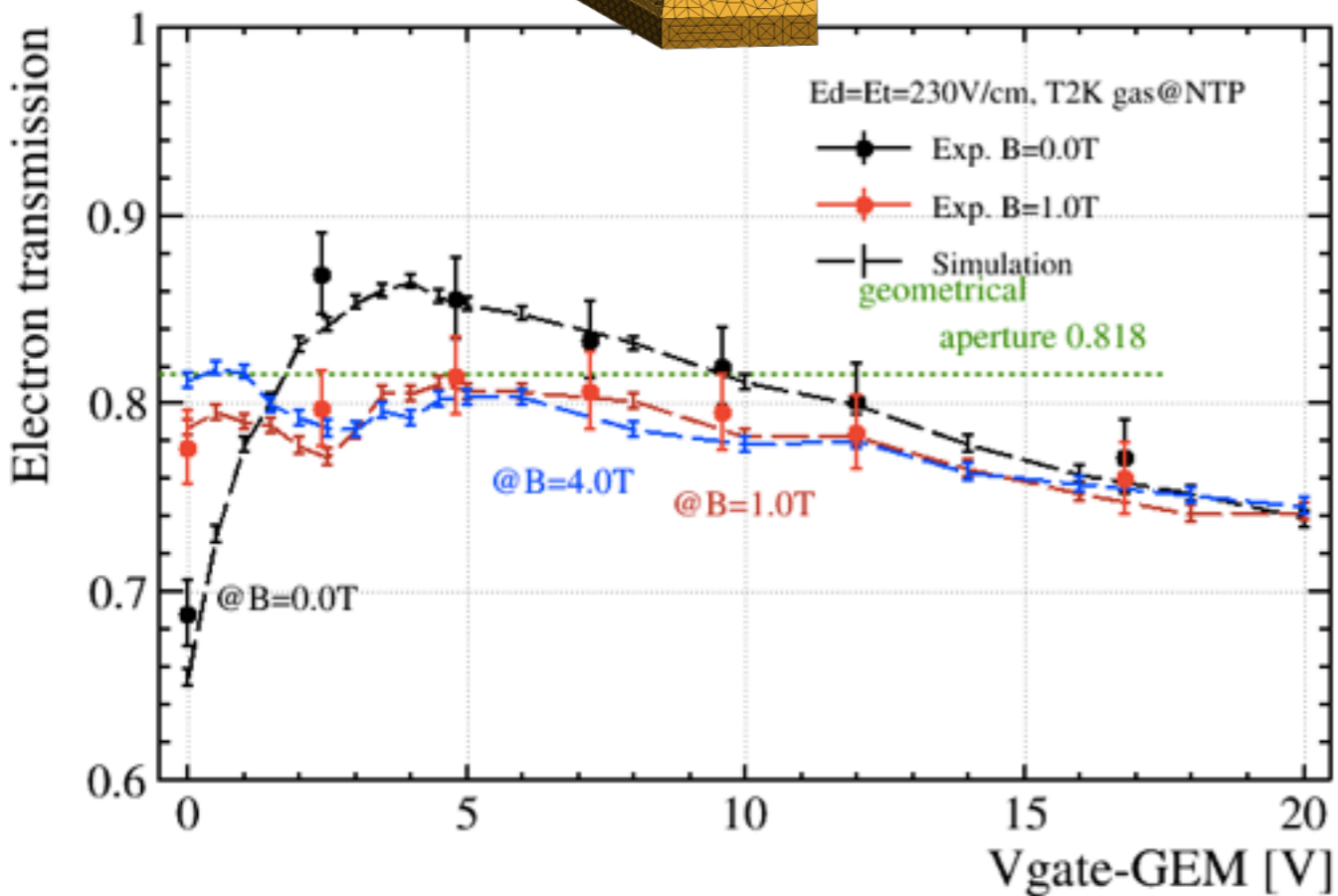
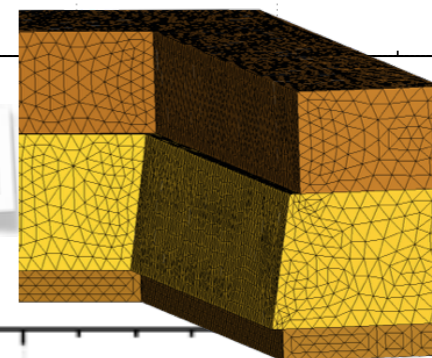
Simulation w/ sub-step approx.



trapezoidal

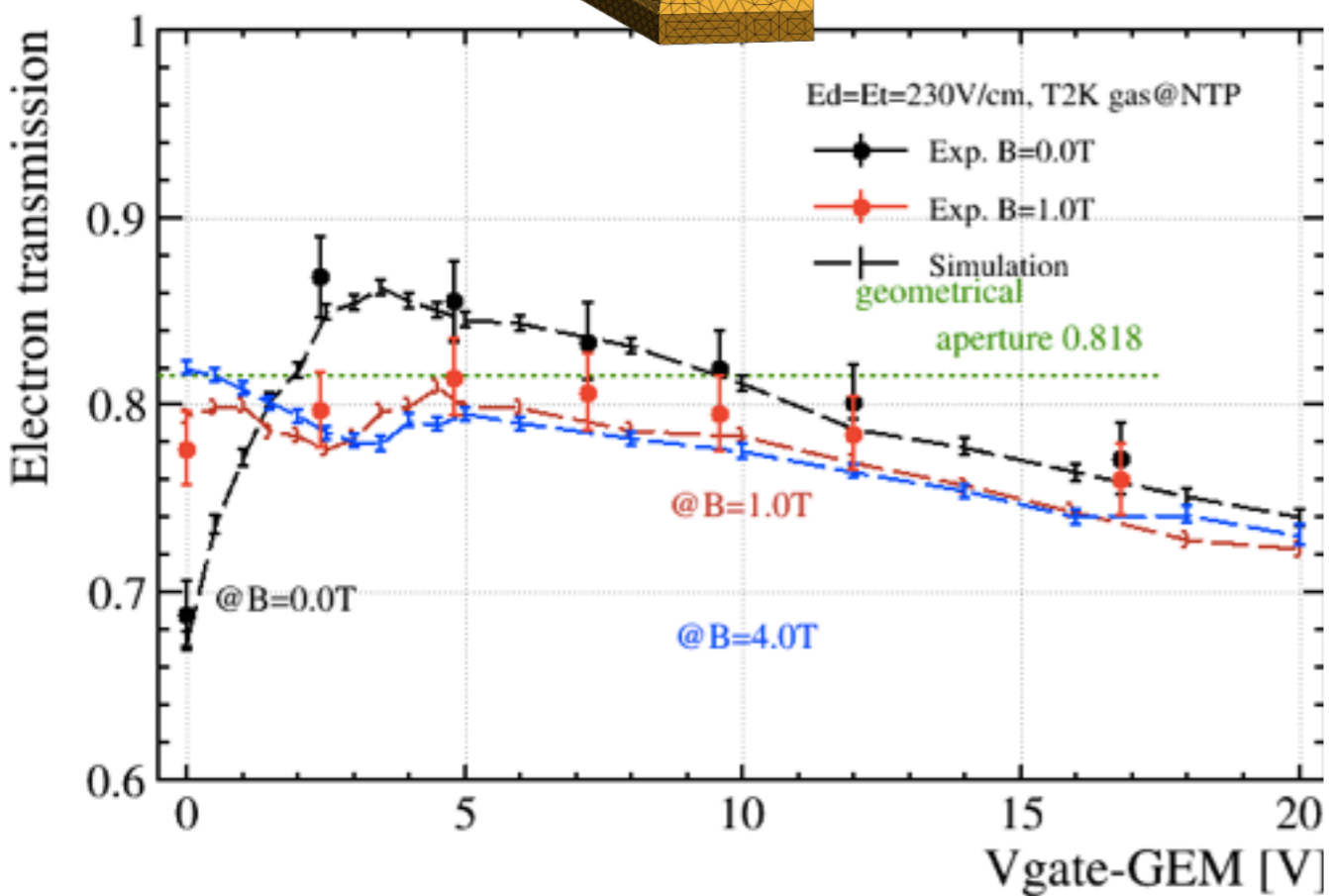
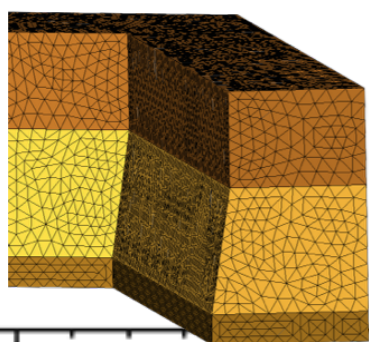


tapered

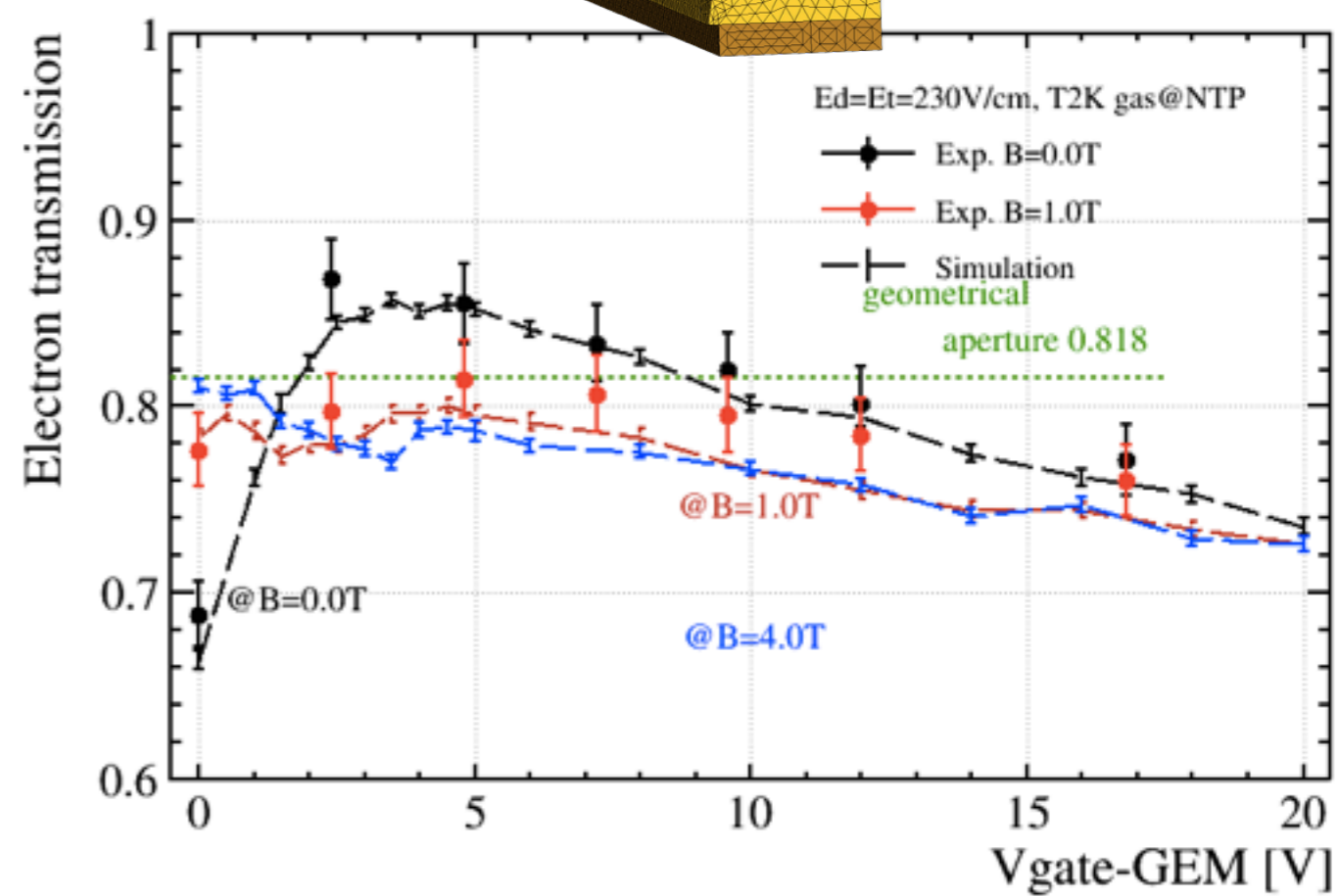
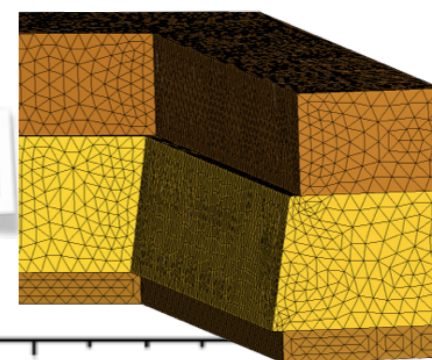


Simulation w/ sub-step

trapezoidal



tapered



Another simulation is the closed state

Textbook
Particle Detection
with Drift Chambers

Ion blocking measurement (exp. data is with an electron)

→ **The key point is diffusion.**

t2k@ 0.0T e^- $\sim 300 \mu\text{m}/\sqrt{\text{cm}}$ (Magboltz.) **230v/cm**
 $\text{Ar}^+, \text{iC}_4\text{H}_{10}^+$ $\sim 142 \mu\text{m}/\sqrt{\text{cm}}$ (textbook, $Dt^2 \sim 1/E\text{-field}$
 an ion has thermal energy
 (thermal balance))

$$\frac{D_T(\omega)}{D_T(0)} = \frac{1}{1 + \omega^2 \tau^2}, \quad \text{textbook}$$

$$\omega\tau = B\mu \simeq \begin{cases} 10^{-4} & \text{for ions} \\ 1 & \text{for electrons} \end{cases}$$

ω : cyclotron frequency
 τ : mean free time

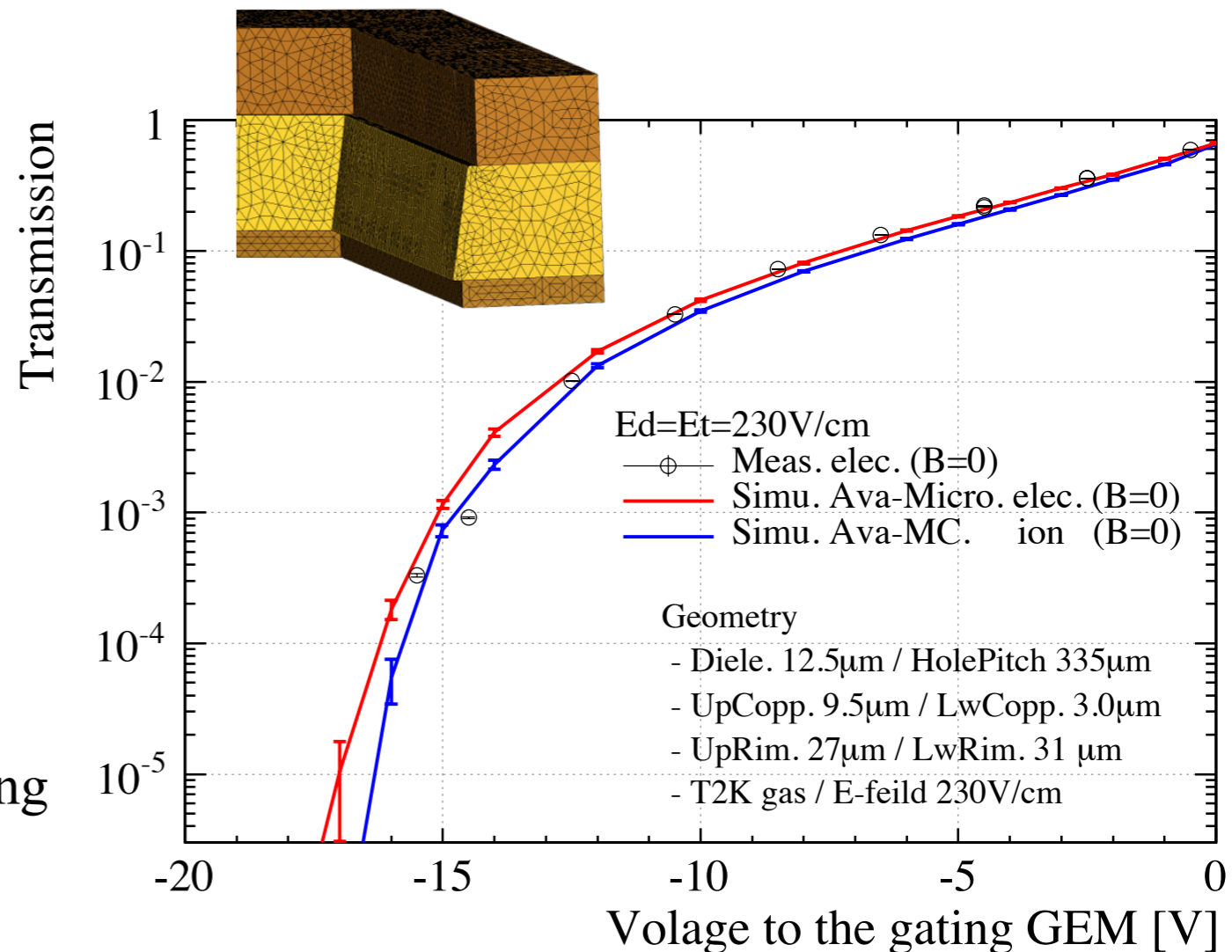
Dt of the ion does not change under B

→ B=0 give enough prediction
for the ion blocking,

Exp. with the electron.

can give the lower limit for the ion blocking

The modified version gives similar result
(electron)



Summary

Simulation was modified for predictions of the behavior of the gating foil
(I need to have discussion with a developer)

The Results reproduce experiment to some extent for 0 and 1 T.

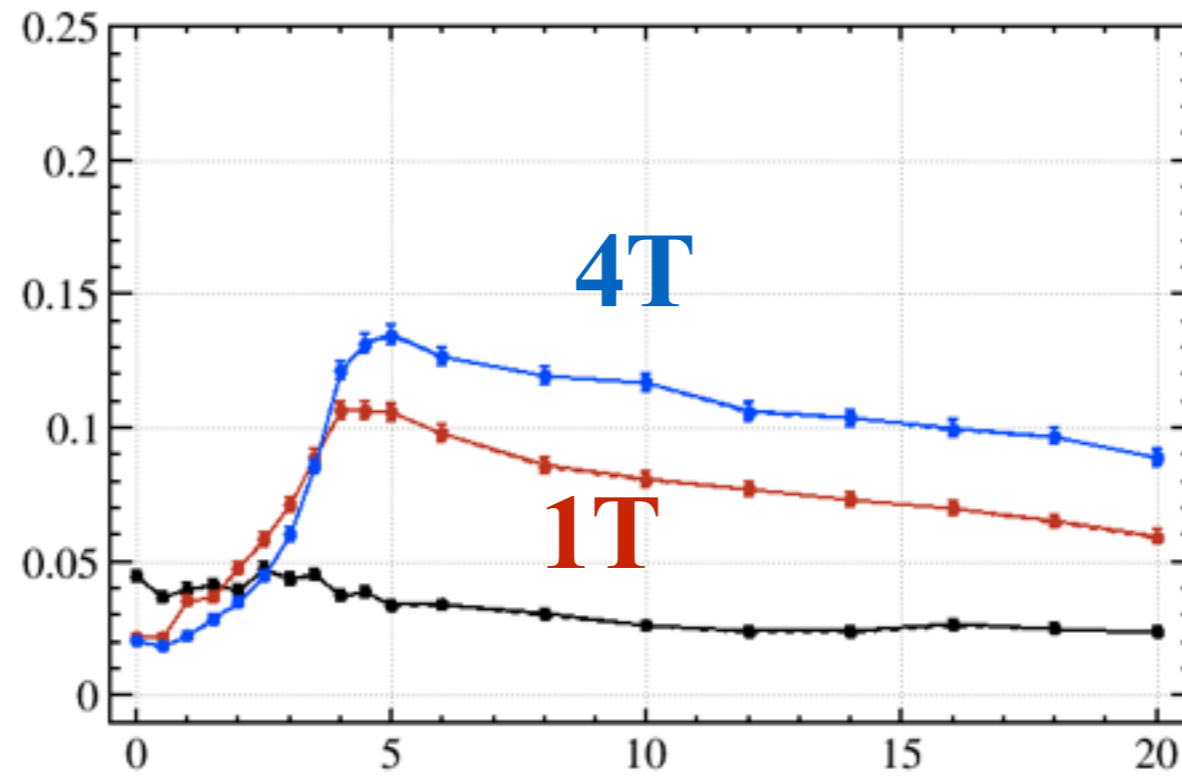
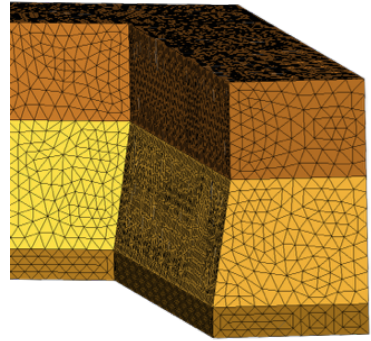
With 0-1 V operation the transmission of $>80\%$ is
PROBABLY achievable under $\sim 3.5/4.0$ T.

Simulation indicate that ion blocking of $<10^{-5}$ even for $<10^{-6}$ is
PROBABLY achievable for a higher B field
with the applied voltage of $< -20V$.

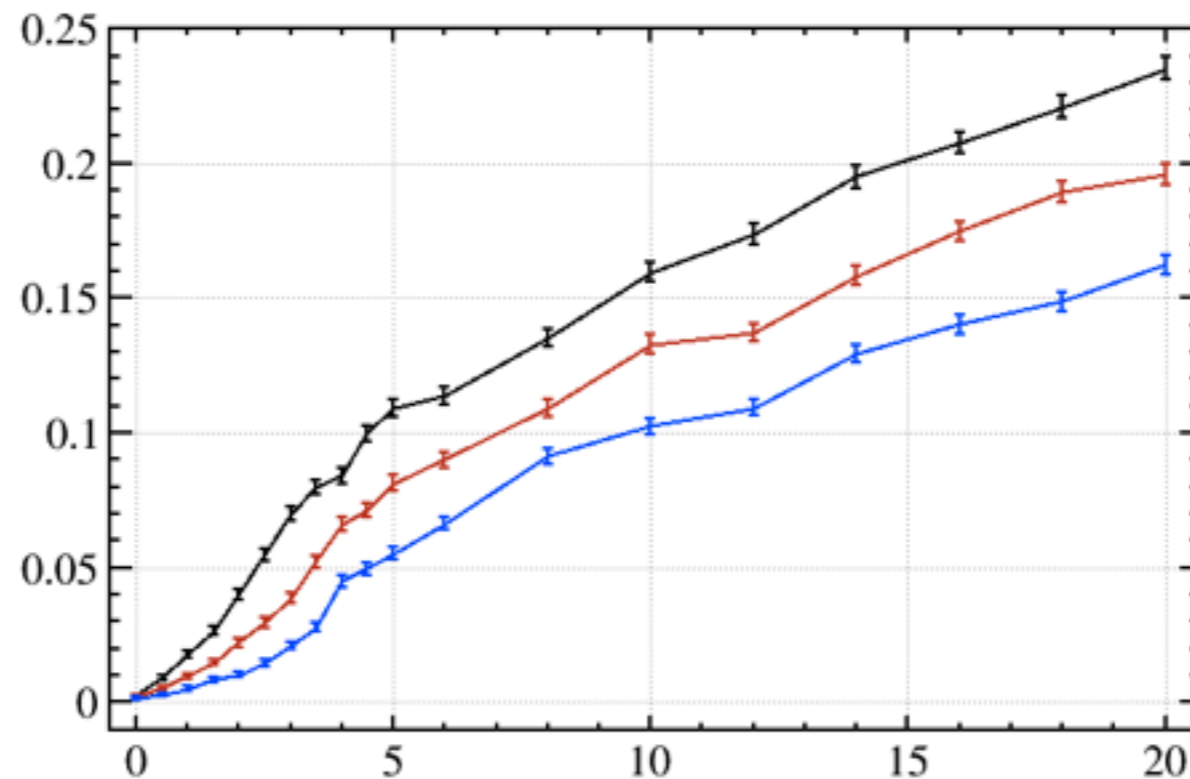
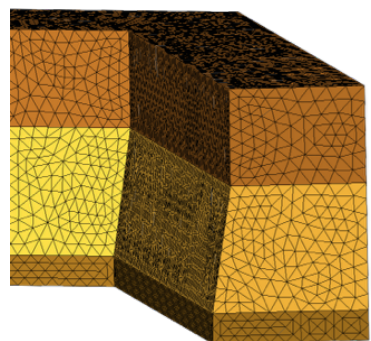
Remaining tasks are 1). direct measurement of ion blocking using the ion itself.
and compare with the simulation (confirmation).

2). actual measurement under the higher B field. (electron/ion)

Ratio reaching to the dielectric



Ratio reaching to a lower copper



Axial Magnetic field

